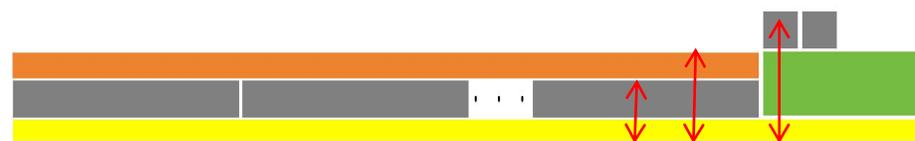
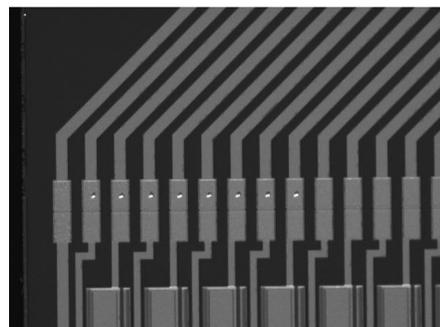
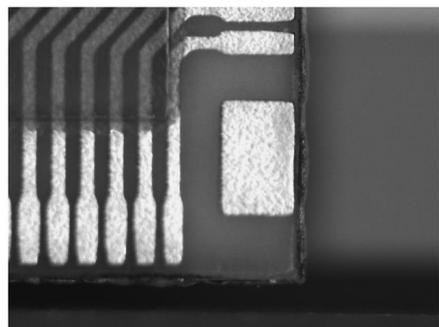
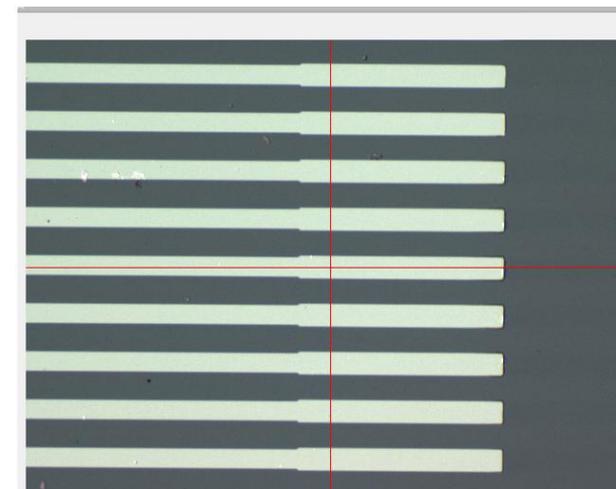
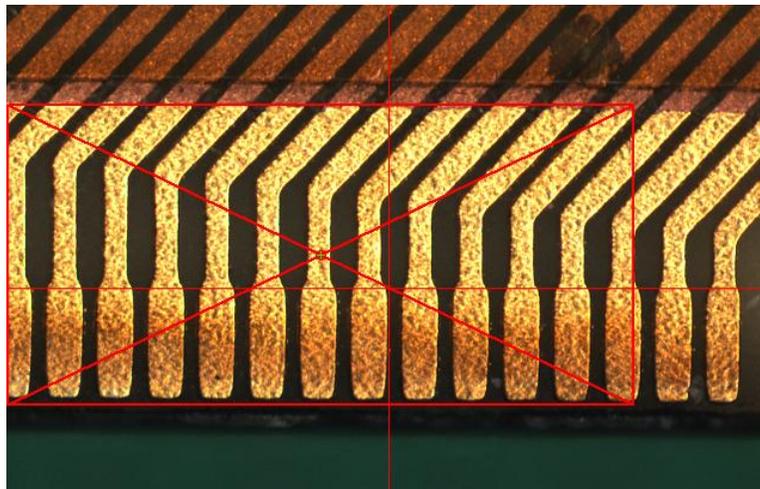
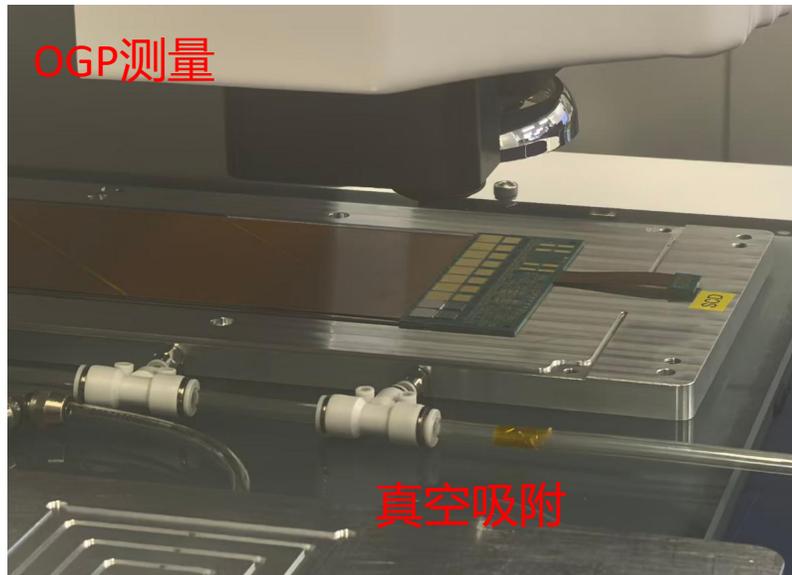


HERD STK/SCD group meeting

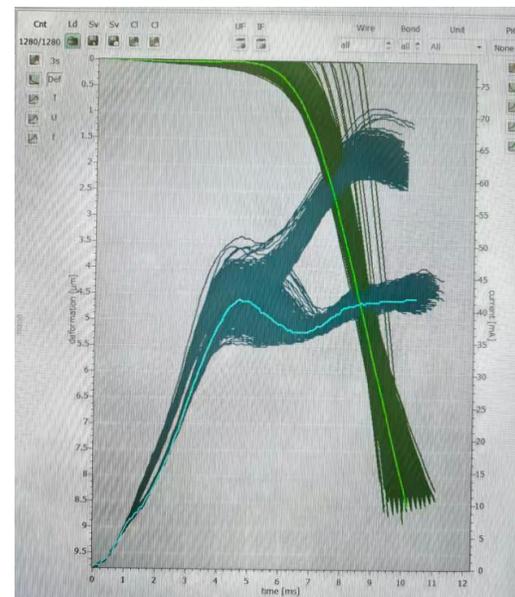
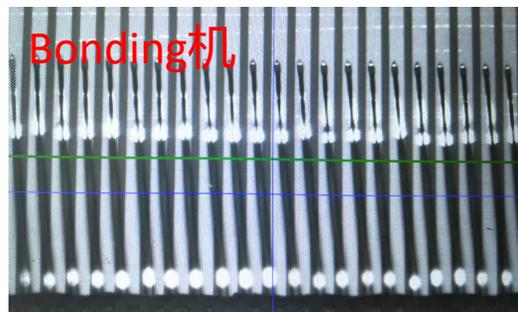
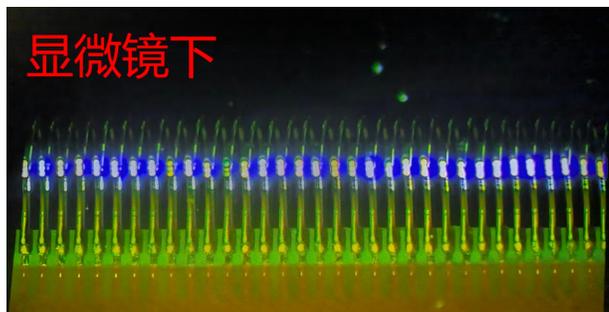
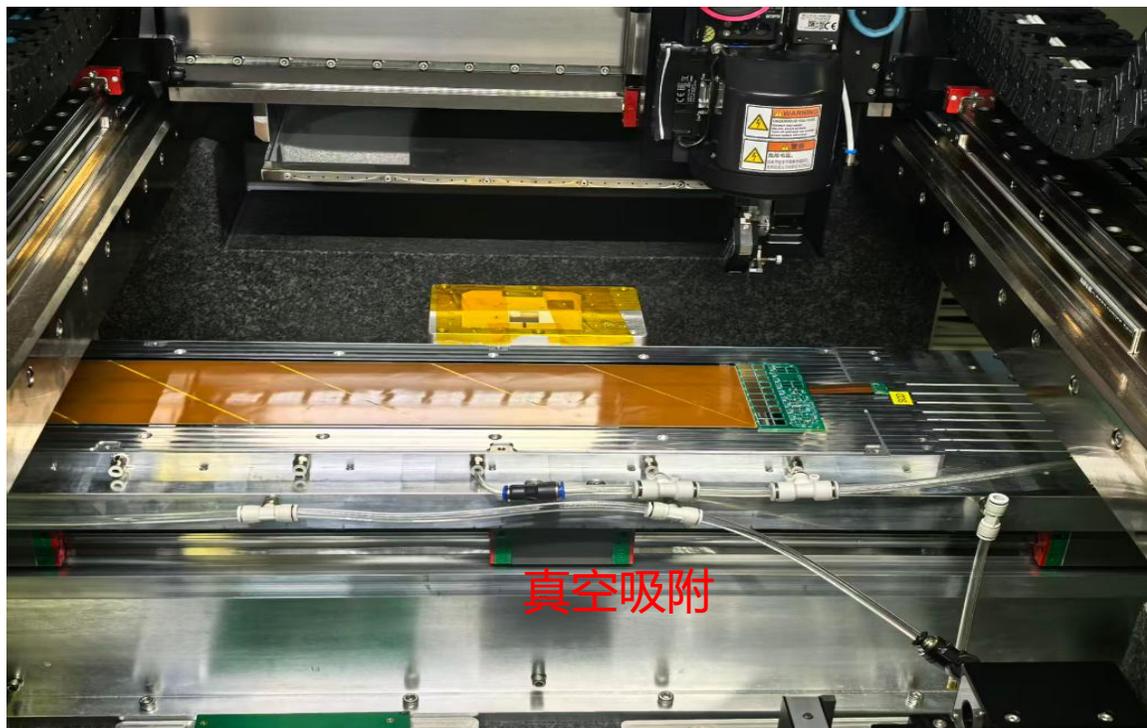
实验物理中心
金梁程龙
2026.01.09

□SCD精度测量



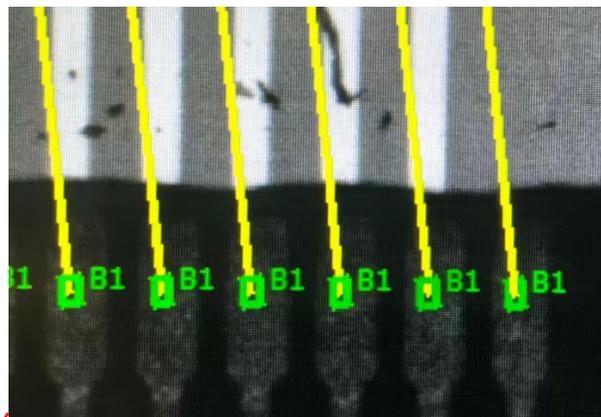
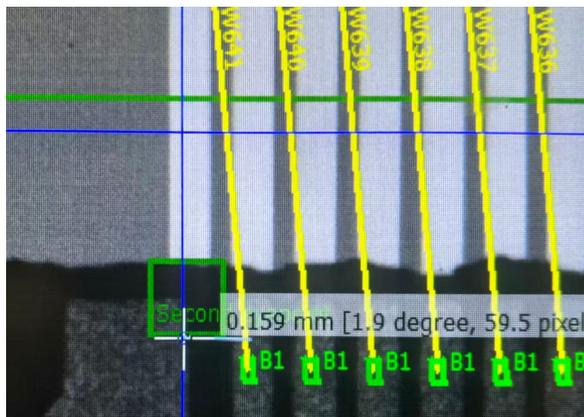
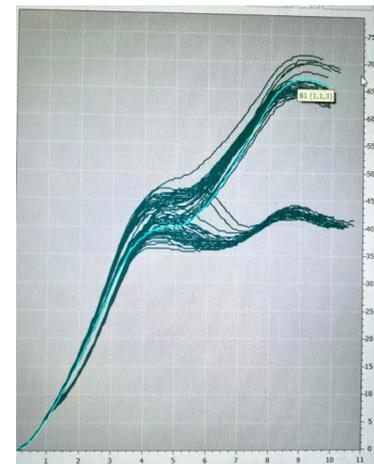
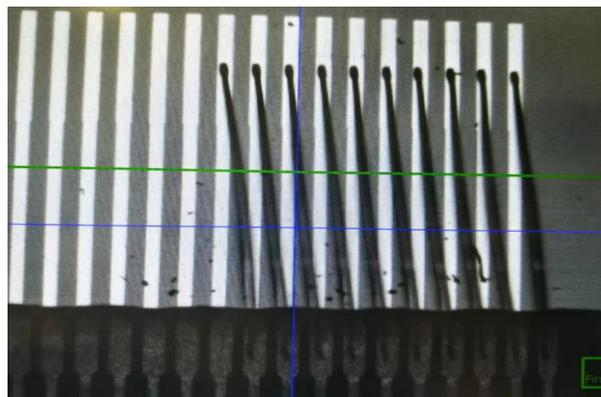
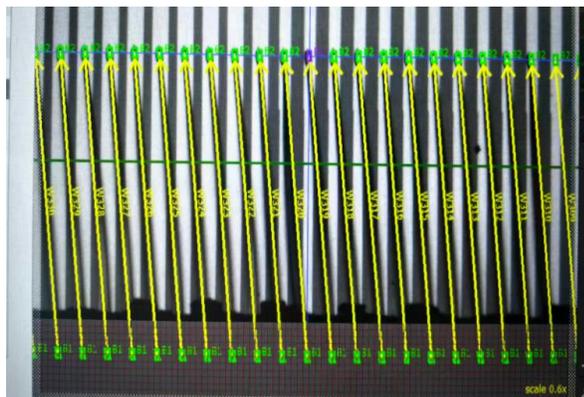
0.7 mm 1.25 mm 1.736 mm

□ Wire bonding



- 基于当前SCD dummy Z型 ladder, 编写完成HERD FPC-SSD (上侧) 的wire bonding 程序, 初步优化了键合参数
- 已完成一组SSD-FPC之间bonding (640根线, 一次成功)
- 弧高参数设置866 μm , 与OGP测量结果一致
- 下一步, 完成FPC-电容之间程序编写, 以及镜像位置的程序

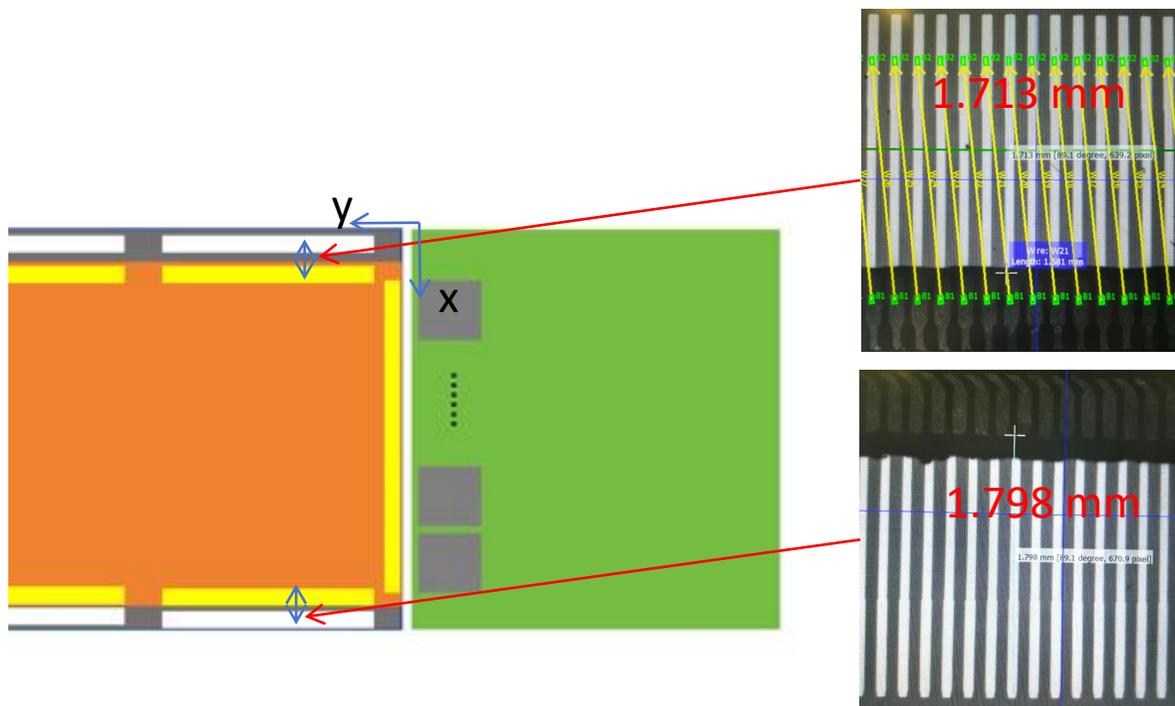
□ FPC粘接精度测量



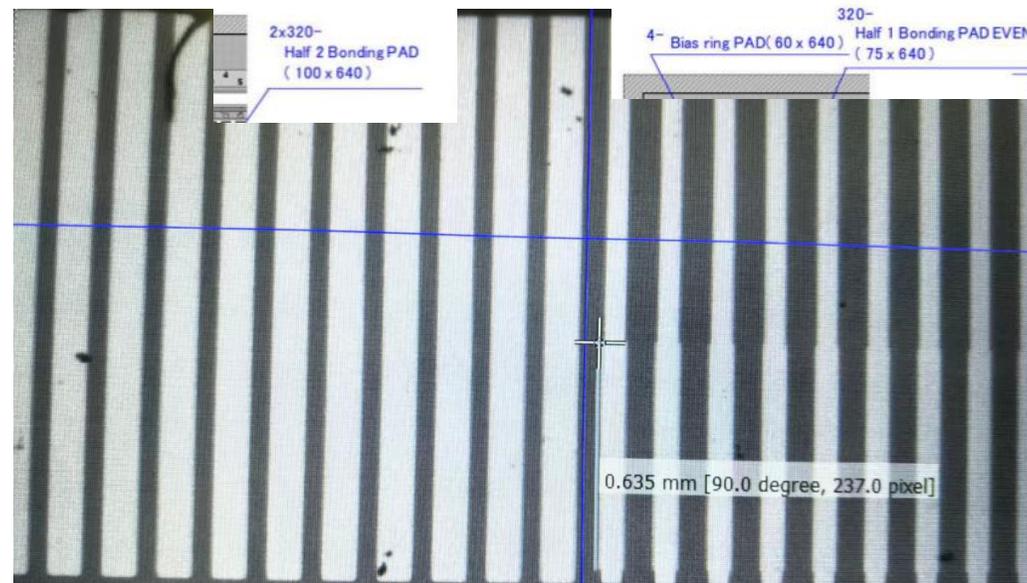
- y方向偏移一个pad (-159 μm)
- 靠近PCB边缘, FPC与SSD之间有显间隙, 导致键合稳定性较差 (10根线左右)



□ FPC粘接精度测量



➤ x方向偏移50 μm



- bonding机视角下，SCD SSD的pad边界不清晰
- 当前Dummy ladder的划痕较为严重

Thanks for your attention